ATTY. DOCKET NO.: P68917US0

TATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Cheol Hwan PARK, et al. Serial No.: 10/600,332

Filed: June 23, 2003

For:

Group Art Unit: 2812 Examiner: Stanetta D. Isaac

METHOD FOR FORMING DEVICE ISOLATION FILM OF SEMICONDUCTOR DEVICE

TRANSMITTAL

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transmitted herewith is an Amendment Under Rule 1.111 and Information Disclosure Statement for filing in the above-captioned patent application.

The fee has been calculated as shown below:

1		1 0		1		Small Entity		Other Than		
	Remaining	Number		Extra			Rate	(or)	Small Entity	
	After	Previously Paid For			1		Additional		Rate	
	Amendment						Fee		Additional Fee	
Total Claims	11	- 20	=	0	x 09	=	\$	$\times 18 =$	\$	
Ind. Claims	1	- 03	=		x 44	=	\$	$\times 88 =$	\$	
Multiple Dependent Claims					<u>+150</u>	=	\$	<u>+300</u> =	\$	
					Total		\$	Total	\$	

XXXX A credit card payment form in the amount of \$180.00 is attached for:

Information Disclosure Statement processing fee

XXXX If a Petition for Extension of Time is necessary and the Petition and/or the credit card payment form is not enclosed, this will act as the Petition and applicant herewith petitions the Commissioner to extend the time for response and charge any fees necessary under 37 CFR 1.17 (a)(1)-(5) to Deposit Account No. 06-1358. The Commissioner is also authorized to charge payment of any other additional fees associated with this communication or credit any overpayment to Deposit Account No. 06-1358. A duplicate copy of this sheet is attached.

> Respectfully submitted, JACOBSON HOLMAN PLLC

Allen S. Melser hy Engr C Sealing
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Res No 40, 475

400 Seventh Street, N.W. Washington, D.C. 20004-2201 Telephone: (202) 638-6666 Date: October 28, 2004

ASM:SCB

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Cheol Hwan PARK, et al.

Serial No.: 10/600,332

Filed: June 23, 2003

Group Art Unit: 2812

Examiner: Stanetta D. Isaac

METHOD FOR FORMING DEVICE ISOLATION FILM OF SEMICONDUCTOR

DEVICE

INFORMATION DISCLOSURE STATEMENT

Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

As a means of complying with the duty of disclosure under 37 CFR § 1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached. The Examiner is requested to make these references of record in the file of this application.

An English language translation of the Abstract for Korean Publication No: 20011016956 is attached.

Submitted herewith is a credit card payment form for the fee of \$180.00 which is the required IDS processing fee under 37 CFR § 1.17(p). Should any additional fee be required in conjunction with the filing of this statement, please charge such fee to Deposit Account No. 06-1358. A duplicate copy of this paper is enclosed.

10/29/2004 CCHAU1

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Respectfully submitted,

JACOBSON HOLMAN PLLC

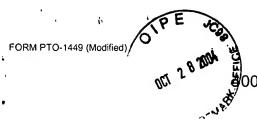
400 Seventh Street, N.W. Washington, DC 20004

Date: October 28, 2004 (202) 638-6666

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LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT

APPLICANT:

Cheol Hwan PARK, et al.

GROUP ART UNIT:

2812

SERIAL NO.:

10/600,332

ATTY. DOCKET NO.:

P68917US0

FILING DATE:

June 23, 2003

TODAY'S DATE:

October 28, 2004

U.S. PATENT DOCUMENTS

*EXAMINER		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE (If Appropriate)
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	АН						
	Al						1
	AJ						
	AK						
	AL						
	AM						

FOREIGN PATENT DOCUMENTS

*EXAMINER		DOCUMENT				SUB-	Translation	
		NUMBER	DATE	COUNTRY	CLASS	CLASS	(Yes)	(No)
	AN	20010106956	12/07/01	Korea			Partial	
	AO							
	AP							
	AQ				·		<u> </u>	
	AR						<u> </u>	
	AS							<u> </u>

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
AU	
AT	

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).